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## **BIB DATA SHEET**

## **CONFIRMATION NO. 9760**

| SERIAL NUM  | IBER FILING or 371(c)   |      | CLASS GR |              | ROUP ART UNIT       |  | ATTORNEY DOCKET  |  |              |                            |
|---|---|------|----------|--------------|---------------------|--|--|--|--------------|----------------------------|
| 10/590,46   |   |      | _        |              | 205                 |  | 1795   |  | 495152003100 |                            |
|   |   | RULE | <u> </u> |              |                     |  |  |  |              |                            |
| APPLICANTS  Hui Wang, Fremont, CA; Afnan Muhammed, Fremont, CA; Jian Wang, Fremont, CA; Felix Gutman, San Jose, CA; Frederick Ho, San Jose, CA; Himanshu J. Chocshi, Fremont, CA; |   |      |          |              |                     |  |  |  |              |                            |
| ** <b>CONTINUING DATA</b> ***********************************   |   |      |          |              |                     |  |  |  |              |                            |
| ** FOREIGN APPLICATIONS ************************************  |   |      |          |              |                     |  |  |  |              |                            |
| ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** ** SMALL ENTITY ** 02/26/2007   |   |      |          |              |                     |  |  |  |              |                            |
| Foreign Priority claimed  35 USC 119(a-d) conditions met Yes No Verified and  Acknowledged  Yes No  Met after Allowance  MICHOLAS A SMITH/ Examiner's Signature  Initials         |   |      |          | iter<br>ance | STATE OR<br>COUNTRY |  | IEETS<br>WINGS<br>14                                       |  |              | INDEPENDENT<br>CLAIMS<br>2 |
| ADDRESS   |   |      |          |              |                     |  |  |  |              |                            |
| HUI DAVID WANG ACM RESEARCH INC. 4378 ENTERPRISE STREET FREMONT, CA 94538 UNITED STATES   |   |      |          |              |                     |  |  |  |              |                            |
| TITLE   |   |      |          |              |                     |  |  |  |              |                            |
| Controlling removal rate uniformity of an electropolishing process in integrated circuit fabrication  |   |      |          |              |                     |  |  |  |              |                            |
|   | FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following: |      |          |              |                     |  | All Fees   |  |              |                            |
| I LIFIIA73 LEE I  |   |      |          |              |                     |  | ☐ 1.16 Fees (Filing) ☐ 1.17 Fees (Processing Ext. of time) |  |              |                            |
|   |   |      |          |              |                     |  | 1.17 Fees (Flocessing Ext. of time)                        |  |              |                            |
| 300   |   |      |          |              |                     |  | Other  |  |              |                            |
|   |   |      |          |              |                     |  | ☐ Credit   |  |              |                            |